

DO NOT ENTER

JLW

12/7/07

EXPEDITED PROCEDURE - EXAMINING GROUP 1746

S/N 10/681,481

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Paul A. Farrar	Examiner:	Michail Kornakov
Serial No.:	10/681,481	Group Art Unit:	1746
Filed:	October 8, 2003	Docket No.:	1303.112US1
Title:	METHOD OF CLEANING SEMICONDUCTOR SURFACES		

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action dated July 24, 2007, please amend the application as follows:

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from October 24, 2007 to November 24, 2007.